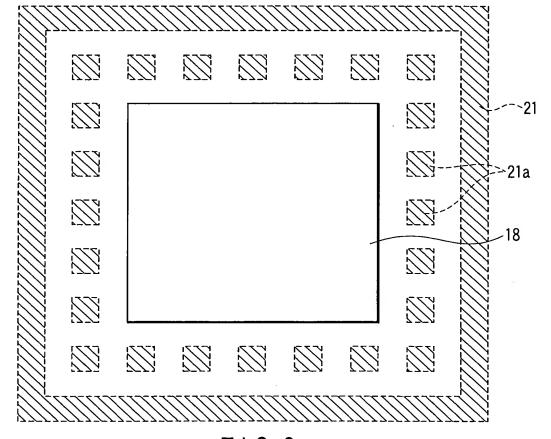


FIG. 8



F I G. 9

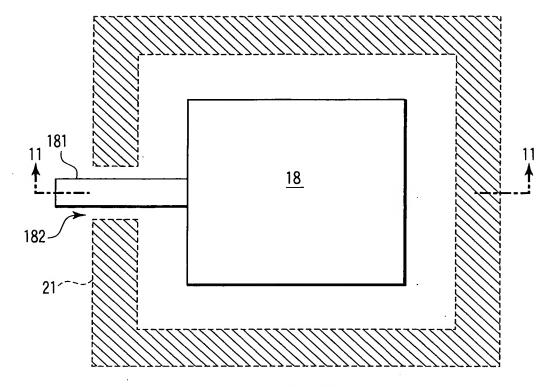
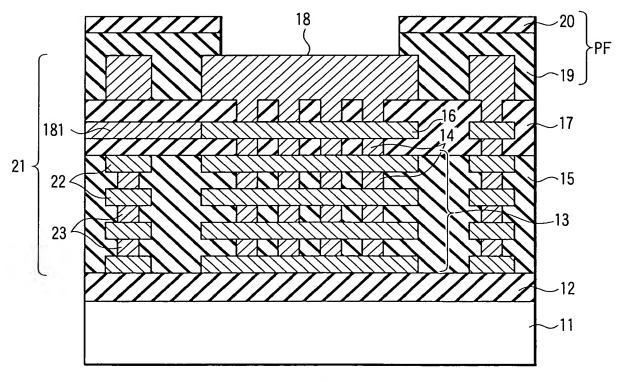


FIG. 10



F I G. 11

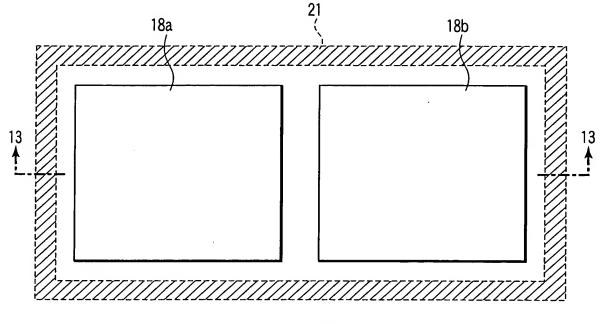
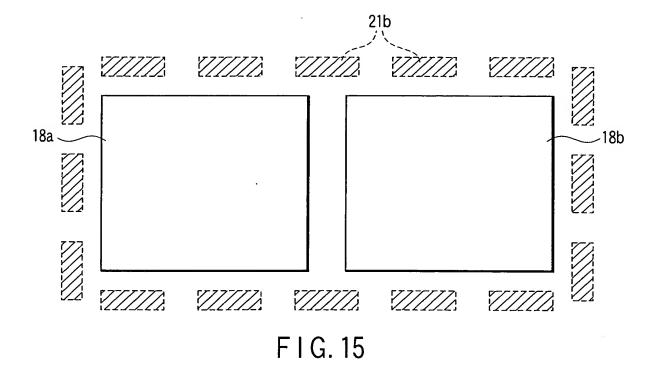


FIG. 12



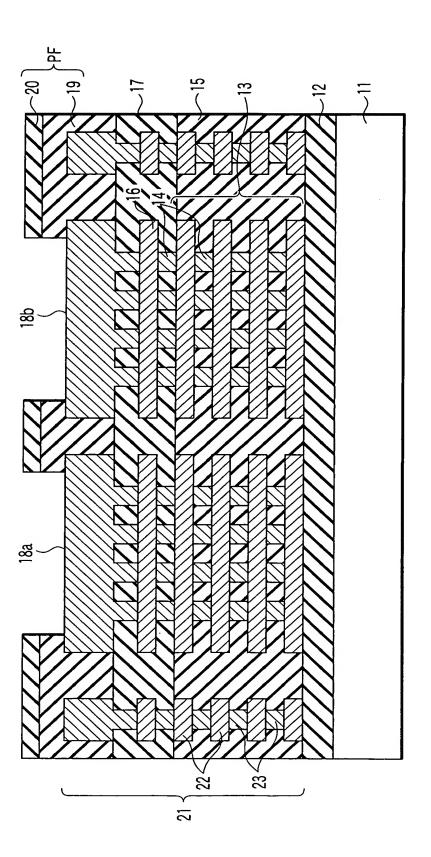
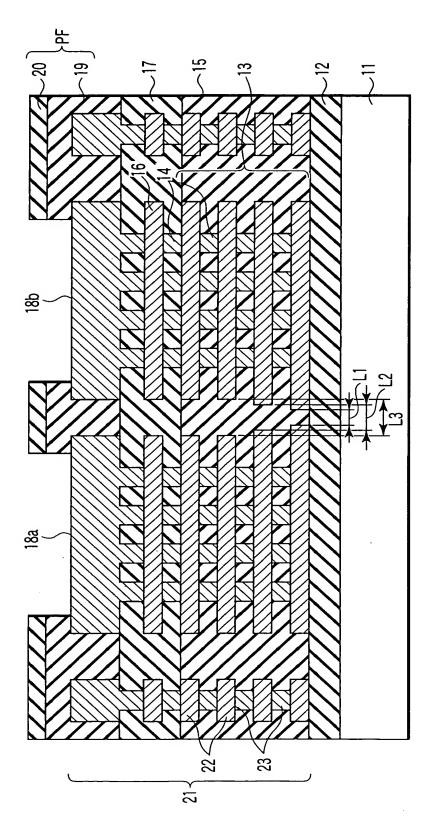
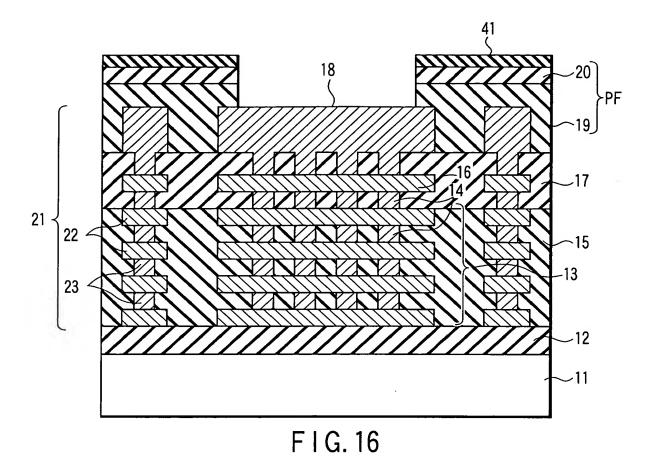
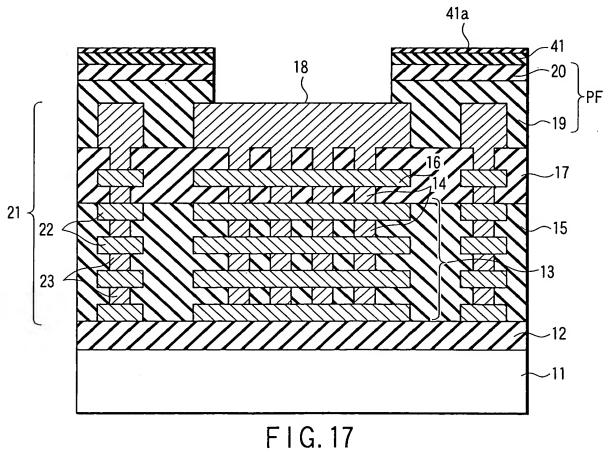


FIG. 13



F1G.14





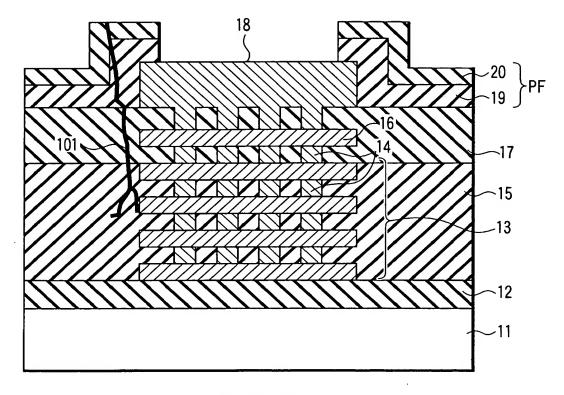
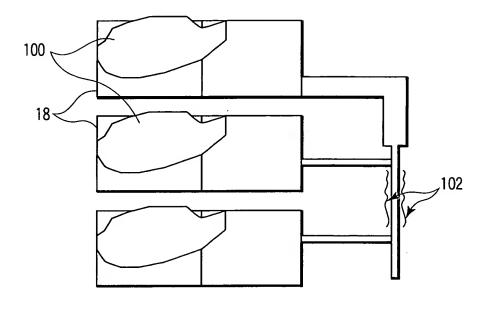


FIG. 18

		Young's modulus (GPa)
Metal material	Copper Tantalum Silicon	150 180 130
Insulating films	SiO <sub>2</sub> SiN	57 98
Insulating films of low dielectric constant	SiOC Organic SiOCH	2-20 1-10

FIG. 19



F I G. 20